

IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

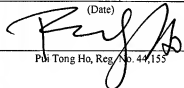
Applicant : Matthew G. Goodman
Application No. : 10/775,522
Filed : February 10, 2004
For : TWO-STAGE LOAD FOR
PROCESSING BOTH SIDES
OF A WAFER
Examiner : Sylvia MacArthur
Art Unit : 1763
Confirmation No. : 1057

CERTIFICATE OF EFS WEB
TRANSMISSION

I hereby certify that this correspondence, and any other attachment noted on the automated Acknowledgement Receipt, is being transmitted from within the Pacific Time zone to the Commissioner for Patents via the EFS Web server on:

October 30, 2007

(Date)



Pui Tong Ho, Reg. No. 44,155

AMENDMENT ACCOMPANYING REQUEST FOR CONTINUED EXAMINATION**Mail Stop RCE**

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Dear Sir:

This paper is responsive to a final Office Action dated June 6, 2007. A response is timely filed within the shortened statutory period with a two-month extension by November 6, 2007.

Amendments to the Claims are reflected in the listing of claims which begins on page 2 of this paper.

Remarks begin on page 4 of this paper.